

Docket No.: Z&P-INFP10306

#5
4-23-02



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant : ANNETTE SAENGER
Filed : CONCURRENTLY HEREWITH
Title : PROCESS FOR THE DEPOSITION OF THIN LAYERS BY
CHEMICAL VAPOR DEPOSITION

INFORMATION DISCLOSURE STATEMENT

Hon. Commissioner of Patents and Trademarks,
Washington, D.C. 20231

Sir:

In accordance with 37 C.F.R. 1.98 copies of the following patents and/or publications
are submitted herewith:

U.S. Patent 5,637,351 (O'Neal et al.), dated June 10, 1997;

Respectfully submitted,

A handwritten signature in cursive script, appearing to read "W. Stemer".

For Applicant

WERNER H. STEMER
REG. NO. 34,956

Date: December 20, 2001

Lerner and Greenberg, P.A.
Post Office Box 2480
Hollywood, FL 33022-2480
Tel: (954) 925-1100
Fax: (954) 925-1101

/kf

FORM PTO-1449 (SUBSTITUTE)

U.S. DEPARTMENT OF COMMERCE
PATENT AND TRADEMARK OFFICEINFORMATION DISCLOSURE
STATEMENT BY APPLICANT
(37 CFR 1.98(b))Attorney Docket No.: Z&P-INFP10306
Appl. No.

Applicant ANNETTE SAENGER

Filing Date December 20, 2001
Group Art UnitJc932 U.S. PTO
10/034053
12/20/01

EXAMINER INITIALS		PATENT NO.	DATE	PATENTEE	CLASS	SUB CLASS	FILING DATE
	A	5,637,351	6/10/97	O'Neal et al.			
	B						
	C						
	D						
	E						
	F						
	G						
	H						
	I						

FOREIGN PATENT DOCUMENT

		DOCUMENT NO.	DATE	COUNTRY	CLASS	SUB CLASS	TRANSL. YES NO
	J						
	K						
	L						
	M						
	N						

OTHER DOCUMENTS (Including Author, Title, Date, Pertinent Pages, etc.)

EXAMINER

DATE CONSIDERED

EXAMINER: Initial if citation considered, whether or not citation is in conformance with MPEP 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.